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**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Attn: OIPE

Masaharu KAWAKUBO et al.

Group Art Unit: 2851

Application No.: 10/581,060

Docket No.: 127873

Filed: May 30, 2006

For: EXPOSURE METHOD AND DEVICE MANUFACTURING METHOD,  
EXPOSURE APPARATUS, AND PROGRAM

**SECOND REQUEST FOR CORRECTION OF PALM RECORDS**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

A Request for Correction of PALM Records was filed on February 16, 2007. A copy of the Request, a marked-up copy of the Official Filing Receipt and a date stamped receipt is attached hereto.

It is respectfully requested that the Corrected Filing Receipt be immediately forwarded to the attorneys of record at the address set forth below.

Respectfully submitted,

Mario A. Costantino  
Registration No. 33,565

Randi B. Isaacs  
Registration No. 56,046

MAC:RBI/ejw

Date: July 13, 2007

**OLIFF & BERRIDGE, PLC**  
**P.O. Box 19928**  
**Alexandria, Virginia 22320**  
**Telephone: (703) 836-6400**

<p><b>DEPOSIT ACCOUNT USE AUTHORIZATION</b> Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461</p>
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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records.

Respectfully submitted,

Mario A. Costantino  
Registration No. 33,565

Stephen P. Catlin  
Registration No. 36,101

MAC:SPC/ejw

Date: February 16, 2007

**OLIFF & BERRIDGE, PLC**  
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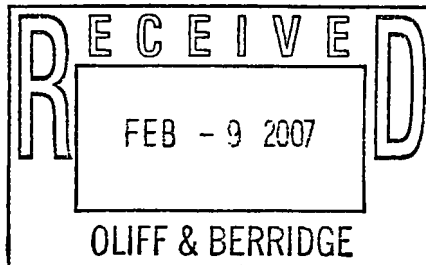


## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
United States Patent and Trademark Office  
Address: COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria, Virginia 22313-1450  
www.uspto.gov

APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/581,060	05/30/2006	2851	2230	127873	13	32	6

25944  
OLIFF & BERRIDGE, PLC  
P.O. BOX 19928  
ALEXANDRIA, VA 22320



CONFIRMATION NO. 6788

## FILING RECEIPT



\*OC000000022361515\*

Date Mailed: 02/07/2007

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

## Applicant(s)

Masaharu Kawakubo, Saitama-ken, JAPAN;  
Yuho Kanaya, Saitama-ken, JAPAN;  
Chiaki Nakagawa, Saitama-ken, JAPAN;  
Takahisa Kikuchi, Saitama-ken, JAPAN;  
Masahiko Akizuki, Saitama-ken, JAPAN;

Power of Attorney: The patent practitioners associated with Customer Number 25944.

## Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP04/17447 11/25/2004

## Foreign Applications

JP 2003-400210 11/28/03

If Required, Foreign Filing License Granted: 02/06/2007

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US10/581,060**

Projected Publication Date: 05/17/2007

Non-Publication Request: No

Early Publication Request: No

**Title**

Exposure method and device manufacturing method, exposure apparatus, and program

**Preliminary Class**

355

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**PTO RECEIPT FOR FILING OF PAPERS**

Delivery ▶ Mail Room

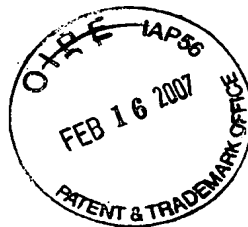
The following papers have been filed:

Request for Correction of PALM; marked-up copy of OFR



<b>Name of Applicant:</b>	Masaharu KAWAKUBO; Yuho KANAYA; Chiaki NAKAGAWA; Takahisa KIKUCHI; Masahiko AKIZUKI
<b>Serial No.:</b>	10/581,060
<b>Attorney File No.:</b>	127873
<b>Title:</b>	Exposure Method and Device Manufacturing Method, Exposure Apparatus, and Program
<b>Sender's Initials:</b>	MAC:SPC/ejw
<b>Assignee:</b>	NIKON CORPORATION

PATENT OFFICE DATE STAMP

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